IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re application of:	§	Group Art Unit: Unknown
Tushar Udeshi et al.	§	
	§	
Serial No. 10/698,178	§	Examiner: Unknown
	§	
Filed: October 31, 2003	§	
	§	
For: SYSTEM AND METHOD FOR	§	
PROCESSING A HIERARCHICAL DATA	§	
TREE	§	

INFORMATION DISCLOSURE STATEMENT

Commissioner For Patents
P.O. Box 1450
Alexandria, VA 22313-1450

Dear Sir:

     In compliance with the duty of disclosure under 37 CFR §1.56, and in accordance with the practice under 37 CFR §1.97 and §1.98, the Examiner's attention is directed to the documents listed on the enclosed modified Form PTO-1449. No inference should be made that the cited references are in fact material, are in fact prior art, or that no better art exists.

     This Information Disclosure Statement is being filed more than three months after the United States filing date and before the mailing date of the first Office Action on the merits. No certification or fee is required (37 CFR §1.97(b)).

     The Commissioner is hereby authorized to charge any additional fees, which may be required or credit any overpayment to Deposit Account 08-1394.

     It is respectfully requested that the above information be considered by the Examiner and that a copy of the enclosed Form PTO-1449 be returned indicating that such information has been considered.

Respectfully submitted,

David L. McCombs
Registration No. 32,271

Date: 3 FEB 2004
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File: 34003.83
R-66035

In place of PTO-1449 Form	U. S. DEPARTMENT OF COMMERCE PATENT AND TRADEMARK OFFICE	*Complete if Known*	
	INFORMATION DISCLOSURE STATEMENT BY APPLICANT *(use as many sheets as necessary)*	Application Number	10/698,178
		Filing Date	October 31, 2003
		Applicant(s)	Tushar Udeshi et al.
		Art Unit	Unknown
		Examiner Name	Unknown
SHEET	OF	Attorney Docket Number	34003.83

U. S. PATENT DOCUMENTS

Examiner's Initials	Cite No.	Document Number	Publication Date MM-DD-YYYY	Name of Patentee or Applicant of Cited Document

FOREIGN PATENT DOCUMENTS

Examiner's Initials	Cite No.	Foreign Patent Document (Country Code – Number – Kind)	Publication Date MM-DD-YYYY	Patentee or Applicant of Cited Document	Translation Y/N

OTHER PRIOR ART

Examiner's Initials	Cite No.	Include name of the author (in CAPITAL LETTERS), title of the article, title of the item, date, page(s), volume-issue number(s), publisher, city/country where published
	AA	E. PARKER, et al., "EXPLOITING SELF-SIMILARITY IN GEOMETRY FOR VOXEL BASED SOLID MODELING", Eight ACM Symposium on Solid Modeling and Applications SM'03, June 16-20, 2003, Seattle, Washington
	AB	E. PARKER, et al., "MEMULATOR: A FAST AND ACCURATE GEOMETRIC MODELING, VISUALIZATION AND MESH GENERATION FOR 3D MEMS DESIGN AND SIMULATION", Nonotech 2003 Volume 2, Technical Proceedings of the 2003 Nanotechnology Conference and Trade Show.
	AC	T. UDESHI, "TETRAHEDRAL MESH GENERATION FROM SEGMENTED VOXEL DATA", 12th International Meshing Roundtable, September 14-17, 2003

Examiner Signature		Date Considered	

EXAMINER: Initial if reference considered, whether or not citation is in conformance with MPEP 609. Draw line through citation if not in conformance and not considered. Include a copy of this form with next communication to applicant.